

**Notice of References Cited**

Application/Control No.

10/542,260

Applicant(s)/Patent Under  
Reexamination  
AN, CHI-YUP

Examiner

Gail Verbitsky

Art Unit

2855

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,915,415	06-1999	Huang, Tien-Tsai	137/551
*	B	US-6,641,305	11-2003	Wang, David	374/148
*	C	US-4,630,940	12-1986	Ostertag et al.	374/148
*	D	US-7,000,850	02-2006	Lin, Pik Fan	236/94
*	E	US-7,246,941	07-2007	Shike, David	374/148
*	F	US-2002/0097777	07-2002	Ronci, Michael Benjamin	374/157
*	G	US-4,743,120	05-1988	Bowen, John G.	374/147
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.